

Notice of References Cited	Application/Control No. 10/614,700		Applicant(s)/Patent Under Reexamination XIN-SHAN ET AL.	
	Examiner Geoffrey Mruk		Art Unit 2853	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,511,161	01-2003	Sumi et al.	347/68
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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